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**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Tsuneo KAGOTANI et al.

Group Art Unit: 2651

Application No.: 10/643,917

Filed: August 20, 2003

Docket No.: 116900

For: MAGNETO-RESISTANCE EFFECT ELEMENT BAR EXPOSURE METHOD,  
MAGNETO-RESISTANCE EFFECT ELEMENT BAR FORMATION METHOD  
AND MAGNETO-RESISTANCE EFFECT ELEMENT BAR

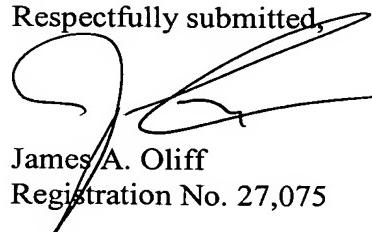
**STATUS INQUIRY LETTER**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please telephone our firm's Patent Application Filing Department at 703-836-6400 with the status of the above-identified patent application, including an indication as to when the next communication can be expected.

Respectfully submitted,



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Date: February 17, 2005

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